



Our advanced manufacturing methods ensure sheet uniformity, metallization adhesion, and thickness control allowing PPI to meet or exceed custom requirements from simple patterned submounts to highly complex boards that include: Transmission Lines Combiners & Splitters, Interposers, Inductors, Filters, Direct Patterns, and Integrated tight tolerance resistors.



- Full In-House Design Capabilities
- Low NRE
- 100% Visual and DC Electrical Inspection
- Element Evaluation & Test Capabilities per MIL-PRF-55342 and MIL-STD-883

**Design Characteristics**

<b>Resistance Tolerance</b>	±0.01% to ±20%
<b>Resistance Ratio</b>	0.01% available
<b>TCR Tracking</b>	±2 ppm/°C
<b>Termination Material</b>	Gold (Standard)
<b>Wafer: Size</b>	Up to 4 in x 4 in
<b>Thickness Tolerances</b>	As low as ±.5 mils for height matching applications
<b>Line Width Definition (Resistor)</b>	0.1 mils
<b>Line Width Definition (Conductor)</b>	0.2 mils
<b>Metals Available</b>	Gold, Nickel, NiChrome, Palladium, Platinum, Tantalum, Tantalum Nitride, Titanium, Titanium Tungsten (TiW), Silver
<b>Specialty Materials</b>	Metallization available on 1 - 6 sides Through-holes (vias), edge wraps, and custom laser cutouts
<b>Patterning Processes</b>	Full Photolithography capabilities and Lift-off patterning available
<b>100% Electrical</b>	Laser test and trim with full mapping (read and record data)
<b>Photolithography</b>	Patterning, wet and dry etching
<b>Electroplating</b>	Nickel and Gold
<b>Wafer Dicing</b>	Silicon, Alumina, Quartz, Beryllium Oxide, Aluminum Nitride, and custom substrates
<b>RF &amp; DC Sputtering</b>	Supporting Au, Pt, Ag, Ni, Pd, Ta, TiW, Ti, Tan, NiCr, and SiO <sub>2</sub> . Custom plating stacks available
<b>Repackaging</b>	Tape and Reel, waffle pack, gel pak, and film frame
<b>Other Capabilities</b>	Gold filled Vias, Gold Bumping



**Resistive Material Characteristics**

Code	Resistive Material	Sheet Resistivity	Passivation	Standard TCR	Optional TCR
T	Tantalum Nitride	5 Ω/sq - 300 Ω/sq	Ta <sub>2</sub> O <sub>5</sub> (self-Passivating)	± 150 ppm/°C	± 50 ppm/°C
N	NiChrome	5 Ω/sq - 250 Ω/sq	SiO <sub>2</sub>	± 25 ppm/°C	± 5 ppm/°C

**Standard Substrate Characteristics**

Code	Substrate Material	Available Thickness (standard)	Dielectric Constant (@ 1MHz)	Thermal Conductivity (W × m <sup>-1</sup> × K <sup>-1</sup> )
20	Quartz	0.005 in - 0.010 in	3.8	1.38
22	Silicon	0.005 in - 0.010 in	N/A (SiO <sub>2</sub> K = 3.8)	149 (SiO <sub>2</sub> 1.38)
25	Beryllium Oxide (BeO)	0.005 in - 0.025 in	6.6	285
28	Aluminum Nitride (AlN)	0.005 in - 0.025 in	8.7	170
35	Alumina (Al <sub>2</sub> O <sub>3</sub> )	0.005 in - 0.025 in	9.8	26.9

**Testing**

Testing Performed	Specification / Standard
Visual Inspection	MIL-PRF-55342 MIL-STD-883
Mechanical Inspection	MIL-PRF-55342
DC Resistance	MIL-PRF-55342 MIL-STD-202
High Temperature Exposure	MIL-PRF-55342
Thermal Shock	MIL-PRF-55342 MIL-STD-202
Resistance to Bonding Exposure	MIL-PRF-55342
Wire Bonding Integrity	MIL-PRF-55342
Life Test	MIL-PRF-55342 MIL-STD-202

